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PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q88662

Takenori OSADA, et al.

Appln. No.: 10/540,513

Group Art Unit: 2826

Confirmation No.: 6641

Examiner: Eduardo A. Rodela

Filed: June 23, 2005

For: COMPOUND SEMICONDUCTOR EPITAXIAL SUBSTRATE AND METHOD FOR
MANUFACTURING THE SAME

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

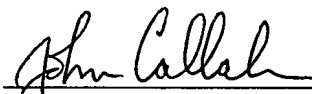
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of
three months, extending the time for responding to the Office Action of March 19, 2007, to
September 19, 2007.

The statutory fee of \$1020.00 is being charged to Deposit Account No. 19-4880. The
USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the
Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said
Deposit Account. A duplicate copy is enclosed.

Respectfully submitted,


John T. Callahan
Registration No. 32,607

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WASHINGTON OFFICE

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CUSTOMER NUMBER

Date: September 13, 2007

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